1

	Application No. Applicant(s)		
Notice of Allowability	10/616,284	YANG ET AL.	
	Examiner	Art Unit	
	Lois Thong	1742	
	Lois Zheng	1742	
The MAILING DATE of this communication apper All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED or other appropriate comn GHTS. This application is	in this application. If not included Tunication will be mailed in due course	:. THIS e initiative
1. This communication is responsive to <u>amendment filed 20 October 2006</u> .			
2. \square The allowed claim(s) is/are $\underline{3}$.			
3. Acknowledgment is made of a claim for foreign priority un a) All b) Some* c) None of the:		or (f).	
1. Certified copies of the priority documents have			
2. Certified copies of the priority documents have			
3. Copies of the certified copies of the priority doc	cuments have been receive	ed in this national stage application fro	m the
International Bureau (PCT Rule 17.2(a)).			
* Certified copies not received:			
Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements noted below. Failure to timely comply will result in ABANDONMENT of this application. THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.			
4. A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient.			
5. CORRECTED DRAWINGS (as "replacement sheets") must be submitted.			
(a) ☐ including changes required by the Notice of Draftsperson's Patent Drawing Review (PTO-948) attached			
1) 🗌 hereto or 2) 🔲 to Paper No./Mail Date			
(b) ☐ including changes required by the attached Examiner's Amendment / Comment or in the Office action of Paper No./Mail Date			
Identifying indicia such as the application number (see 37 CFR 1.84(c)) should be written on the drawings in the front (not the back) of each sheet. Replacement sheet(s) should be labeled as such in the header according to 37 CFR 1.121(d).			
6. DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL.			
Attachment(s) 1. ☐ Notice of References Cited (PTO-892)	5 🗆 Notice of I	nformal Datant Application	
2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)		nformal Patent Application	
3. ☑ Information Disclosure Statements (PTO/SB/08),	Paper No	Summary (PTO-413), ./Mail Date s Amendment/Comment	
Paper No./Mail Date 11/14/06, 11/07/06 4. Examiner's Comment Regarding Requirement for Deposit			
of Biological Material		s Statement of Reasons for Allowance	
	9. 🗌 Other	_··	
•			

Application/Control Number: 10/616,284 Page 2

Art Unit: 1742

DETAILED ACTION

Status of Claims

1. Claim 3 is amended in view of the amendment filed 20 October 2006.

Examiner's Amendment

- 2. The specification is amended as below:
 - a. Page 12, paragraph [0050], insert "now abandoned, " after "entitled 'Multi-Chemistry Electrochemical Processing System', ".
 - b. Page 59, paragraph [00129], insert "now U.S. Patent No. 7,025,862, " after "U.S. Patent Application Serial No. 10/278,527, ".
 - c. Page 61, paragraph [00132], insert "now U.S. Patent No. 6,551,484, " after "U.S. Patent Application Serial No. 09/766,060, ".
 - d. Page 65, paragraph [00140], insert "now U.S. Patent No. 6,911,136, " after "U.S. Patent Application Serial No. 10/135,546,".

Allowable Subject Matter

- 3. Claim 3 is allowed.
- 4. The following is an examiner's statement of reasons for allowance: The prior art of record does not teach or fairly suggest either alone or in combination, the claimed electrochemical plating apparatus comprising the claimed substrate plating cell, the claimed substrate bevel cleaning cell, the claimed stacked substrate annealing station with each of its chambers comprising a substrate heating plate and a substrate cooling plate, and the claimed spin rinse dry cell comprising a cell bowl, an annular inwardly

Application/Control Number: 10/616,284 Page 3

Art Unit: 1742

curving pressure reducing surface, a fluid receiving shield having a plurality of holes, a rotatable substrate support member and a fluid dispensing nozzle.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Lois Zheng whose telephone number is (571) 272-1248. The examiner can normally be reached on 8:30am - 5:00pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Roy King can be reached on (571) 272-1244. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

一儿

lly 1/3/07